PURDUE Ε R

Effects of lithium on chemical sputtering, physical sputtering, and deuterium pumping on graphitic substrates

C.N. Taylor¹, J.P. Allain¹, B. Heim¹, H.W. Kugel², R. Kaita², C. H. Skinner², R. Majeski²

¹Purdue University, West Lafayette, IN 47907 ²Princeton Plasma Physics Laboratory, Princeton, NJ 08543

NP6.00087



Abstract

Lithium research has been conducted in various tokamak devices such as TFTR, CDX-U, FTU, T-11M and NSTX, as a means of enhancing plasma performance. Lithium has been found to reduce hydrogen recycling and facilitate H-mode power threshold. No systematic data is available on D retention and surface chemistry properties of lithiated graphite structures. The presence of lithium in graphite reduces erosion (either physical or chemical sputtering) by factors between 10-30. For pure lithium surfaces D retention can reach levels of 1:1 and the mechanism consists of a combination of D retention in solution with Li (liquid state) and precipitation into Li-D solid crystallites based on the solubility limit of D in Li. For the case of lithiated graphite and its effect on D retention and subsequent sputtering by the plasma the mechanisms are more complex. The chemical state of Li, C and O become critical to understand the role Li plays in pumping D. This work therefore includes well-diagnosed in-situ studies of lithiated graphite

NSTX PFCs post-exposure analysis

Sample locations in NSTX



PPPL removed 23 Si witness samples (ws) from NSTX. After the samples were exposed to atmospheric conditions, a passive oxidized layer began to form on the surface. In addition, three tiles were cored yielding about 5 samples per tile. Analysis of these samples at Purdue University indicated the need of conducting control experiments with in-situ analysis to avoid ambient air exposure effects. These control experiments will provide





exposed to controlled conditions and compared to post-exposure samples from NSTX.

Surface Characterization Methods

The Omicron system is located at Birck Nanotechnology Center at Purdue University. This system is specifically for surface analysis and uses a variety of methods to determine the surface chemistry and physical properties of sample substrates. Characterization techniques include quadrupole mass spectroscopy (QMS), thermal desorption spectroscopy (TDS), X-ray photoelectron spectroscopy (XPS), high resolution electron energy-loss spectroscopy (HR-EELS), and contains in-situ Scan Tunneling Microscopy (STM). In addition, Omicron employs several methods for surface modification including evaporation sources, ion guns, and x-ray sources.

METHODS

• XPS scans are performed on each sample before surface modification, after surface modification, and after any process (ie. TDS) (dwell=0.8ms, step=0.05eV) Omicron surface characterization Cluster • Lithium is deposited via a lithium evaporator. Typically, 2000 nm are deposited. • Samples are bombarded (irradiated) with 1 keV (500 ev/amu) deuterium, 25 min.

Samples are heated for TDS (570 °C for 20 minutes

NSTX tiles are bombarded (irradiated) with Ar⁺ to clean the passivated surface.

Lithium Surface Chemistry

Lithiated control samples are compared to the NSTX tiles to determine the mechanism lithium deuterium. which by pumps



Peaks shown are: Control Samples

O1s

(Birck Nanotechnology Center)

Discussion and Conclusions

- □ XPS Analysis of NSTX tiles and controlled reference samples from laboratory experiments show discernable changes in surface chemistry induced by presence of lithium.
- \Box From the reference cases the peak corresponding to 529.5 eV \pm 0.8 eV is independent of D2⁺ exposure and heat. This peak therefore consists strictly of a Li and oxygen interaction (binding).



- \Box D2⁺ bombardment in the lab experiments lead to similar surface chemical state compared to NSTX tile surfaces (after Ar cleaning) corresponding to a peak at 533 eV. Therefore this peaks consists strictly of a D interaction with lithiated graphite.
- □ Post-exposure NSTX tile core samples show a complex chemistry dependent on location along the divertor in NSTX (e.g. amorphous state in PFR sample).
- □ Results also provide a means to conduct well-diagnosed experiments under *similar* surface conditions as those found after multiple exposure campaigns in NSTX. A new in-situ probe in NSTX will help correlate effect of specific shots with surface chemical state and couple to lab experiments.

Future Work

- □ As detailed analysis has indicated laboratory experiments can help elucidate on some underlying mechanisms for lithium graphite interaction with hydrogen isotopes.
- □ However, correlation to specific NSTX shots must be done with surface analysis insitu *in addition to* post-exposure measurements in lab experiments at Purdue
- □ This effort has motivated the use of an in-situ surface analysis probe integrated near the inner divertor of NSTX to work in close proximity with the LLD

NSTX Surface Analysis Probe

The primary purpose of a surface analysis probe is to perform an *in*situ analysis of plasma facing surfaces to determine the role of lithium and the mechanism by which lithium pumps deuterium. Samples attached to a witness plate will be brought to the plasma facing surface to be exposed for a specified number of shots.



Acknowledgements

We would like to thank Purdue University Graduate School for providing student funding, Lane Roguemore (PPPL) for consultation with the Purdue probe design and Larry Guttadora (PPPL) for coring of NSTX samples , L. Kollar and T. Morton for their contributions with data analysis and experiments, and D. Zemlyanov of the Birck Nanotechnology Center at Purdue University for surface analysis with the KRATOS XPS system. Work supported by USDOE Contract DE-FG02-08ER54990.

¹ W.L. Wampler, "Ion Beam Analysis of Lithium on Tiles from NSTX" SNL, 2007. ² W.L. Wampler, "Ion Beam Analysis of Deuterium on Tiles from NSTX" SNL, 2007.



PURDUE

ENGINEERING

50th Annual Meeting of the Division of Plasma Physics November 17-21, 2008, Dallas, Texas

